

CERTIFICATE

OF PARTICIPATION

This certifies that

Hasan Ali Tawfeeq

has participated and presented a paper entitled:

Effect of Thickness on the Structural and Optical Properties of Cadmium Oxide Thin Films Deposited by Thermal Vacuum Evaporation Technique

> at the 3rd International Conference on Advanced Engineering, Technology, and Applications, held at the University of Catania, Italy on May 24-25, 2024.

Dr. Alessandro Ortis General Chair